

<b>Notice of References Cited</b>	Application/Control No. 10/574,507		Applicant(s)/Patent Under Reexamination WANG ET AL.	
	Examiner ELI MEKHLIN		Art Unit 1793	Page 1 of 1

**U.S. PATENT DOCUMENTS**

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*	B	US-6,361,861	03-2002	Gao et al.	428/367
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Shang et al. Chemical Physics Letters 358 (2002) 187-191.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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